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(54) LASER PROCESSING METHOD

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(57)ABSTRACT

A laser processing method for an electrode is provided that can suppress reduction in a light condensing property for a laser due to a dust, such as fume, while suppressing vibration at a laser processing time. By the present disclosure, a method for performing a laser processing on a strip-like shaped electrode is provided. The herein disclosed method includes carrying the strip-like shaped electrode to a previously set processing area in a longitudinal direction, and includes performing laser radiation on a surface of the electrode in the processing area under a state where a first air flow configured to flow on one surface of the electrode and a second air flow configured to flow on the other surface of the electrode are formed.

